

12-27-2001

IN THE U



TRADEMARK OFFICE

Docket No.: AMD-G0439

101925953

I hereby certify that this transmittal of the below described document is being deposited with the United States Postal Service in an envelope bearing First Class Postage and addressed to the U.S. Patent and Trademark Office, Assignment Branch, North Tower Building, Suite 10C35, Washington, D.C., 20231, on the below date of deposit.

| | | | | | |
|------------------|----------|------------------------------------|--------------|---|---------------------|
| Date of Deposit: | 12/12/01 | Name of Person Making the Deposit: | ANTHONY CHOU | Signature of the Person Making the Deposit: | <i>Anthony Chou</i> |
|------------------|----------|------------------------------------|--------------|---|---------------------|

The Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

Please record the attached original document(s) or copy(ies) thereof:

Transmittal of an Assignment

1. Name of conveying party(ies): Nian Yang, Zhigang Wang and Tien-Chun Yang
Serial No.:
Filed: 12/12/01

Group Art Unit:
Examiner:

2. Name and Address of Receiving party(ies): Advanced Micro Devices, Inc.
One Micro Place, Sunnyvale, CA 94088-3453

3. Nature of Conveyance: Assignment
Execution Date: 12/10/01, 12/10/01, 12/10/01

10017832

4. New Patent Application entitled: METHOD OF DETERMINING GATE OXIDE THICKNESS OF AN OPERATIONAL MOSFET

5. Name and address of party to whom correspondence concerning document should be mailed:

Name: John P. Wagner, Jr.
Address: Wagner, Murabito & Hao LLP
Two North Market Street, Third Floor, San Jose, CA 95113
Phone: (408) 938-9060

6. Total Number of applications and patents involved: ONE

7. **Fee Calculation** (for other than a small entity)

Assignment Recordation Fee, per property

1 X \$40.00

Total Fees (37 CFR 3.41)

\$40.00

X The amount of \$ 40.00 is enclosed

8. At any time during the pendency of this application, please charge any additional fees required or credit any overpayments to Deposit Account 23-0085. A duplicate copy of this transmittal is enclosed.

9. Statement and signature:

To the best of my knowledge and belief, the foregoing information is true and correct and any attached copy is a true copy of the original document.

Date: December 12, 2001

Name: John P. Wagner, Jr.
Reg. No. 35,398

12/20/2001 EHAILE1 00000059 10017832

03 FC:581

40.00 OF

Assignment to Advanced Micro Devices, Inc.

In consideration of good and valuable consideration, receipt of which is hereby acknowledged, I/we

Nian Wang Yang
do hereby sell, assign, and transfer unto Advanced Micro Devices, Inc (hereinafter called AMD), a Delaware Corporation having its principal place of business at One AMD Place Sunnyvale, CA 94088-3453, and its successors and assigns, the entire right, title, and interest for the United States and all foreign countries, in and to any and all improvements, including the right of priority in, to, and under, the application for the United States patent entitled:

METHOD OF DETERMINING GATE OXIDE THICKNESS OF AN OPERATIONAL MOSFET

☒ filed herewith and the inventions set forth and described therein, and any and all Letters Patent of the United States and of countries foreign thereto which may be granted thereon or therefor; or

Serial No.: _____ filed on _____ and the inventions set forth and described therein, and any and all Letters Patent of the United States and of countries foreign thereto which may be granted thereon or therefor;

And for the above consideration, I/we agree promptly upon request of AMD, its successors or assigns, to execute and deliver without further compensation any power of attorney, assignment, application, whether original, continuation, divisional or reissue, or other papers which may be necessary or desirable fully to secure to AMD, its successors and assigns, the inventions described in said application and all patent rights therein, in the United States and in any country foreign thereto, and to cooperate and assist in the prosecution of interference proceedings involving said inventions and in the adjudication or reexamination of said Letters Patent provided the expenses which may be incurred by me/us in lending such cooperation and assistance are paid by AMD.

I/we further covenant with AMD, its successors, assigns, and legal representatives that no assignment, grant, mortgage, license, or other agreement affecting the rights and property herein conveyed has been made to others by the undersigned, and that full right to convey the same as herein expressed is possessed by the undersigned;

In witness whereof, I/we hereunto set my/our hand(s) and seal:

Inventor's Signature: _____

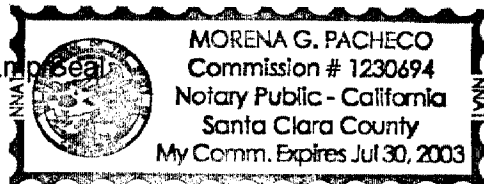
Date: 12/10/01

State of California

County of Santa Clara

Before me this 10th day of December 2001 personally appeared Nian Yang who is _____ personally known or ☒ proved to me on the basis of satisfactory evidence to be the person who acknowledged the foregoing instrument of assignment to be ☒ his or _____ her free act and deed.

Notary Stamp or Seal



Notary Public

Assignment to Advanced Micro Devices, Inc.

In consideration of good and valuable consideration, receipt of which is hereby acknowledged, I/we

Zhigang Wang

do hereby sell, assign, and transfer unto Advanced Micro Devices, Inc (hereinafter called AMD), a Delaware Corporation having its principal place of business at One AMD Place Sunnyvale, CA 94088-3453, and its successors and assigns, the entire right, title, and interest for the United States and all foreign countries, in and to any and all improvements, including the right of priority in, to, and under, the application for the United States patent entitled:

METHOD OF DETERMINING GATE OXIDE THICKNESS OF AN OPERATIONAL MOSFET

X filed herewith and the inventions set forth and described therein, and any and all Letters Patent of the United States and of countries foreign thereto which may be granted thereon or therefor; or

Serial No.: _____ filed on _____ and the inventions set forth and described therein, and any and all Letters Patent of the United States and of countries foreign thereto which may be granted thereon or therefor;

And for the above consideration, I/we agree promptly upon request of AMD, its successors or assigns, to execute and deliver without further compensation any power of attorney, assignment, application, whether original, continuation, divisional or reissue, or other papers which may be necessary or desirable fully to secure to AMD, its successors and assigns, the inventions described in said application and all patent rights therein, in the United States and in any country foreign thereto, and to cooperate and assist in the prosecution of interference proceedings involving said inventions and in the adjudication or reexamination of said Letters Patent provided the expenses which may be incurred by me/us in lending such cooperation and assistance are paid by AMD.

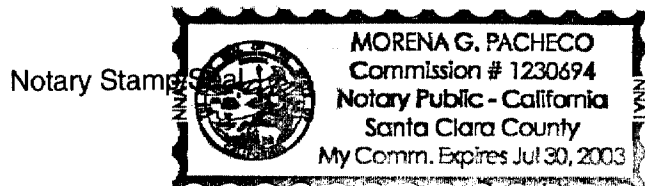
I/we further covenant with AMD, its successors, assigns, and legal representatives that no assignment, grant, mortgage, license, or other agreement affecting the rights and property herein conveyed has been made to others by the undersigned, and that full right to convey the same as herein expressed is possessed by the undersigned;

In witness whereof, I/we hereunto set my/our hand(s) and seal:

Inventor's Signature: *[Signature]* Date: 12/10/01

State of California
County of Santa Clara

Before me this 10th day of December 2001 personally appeared Zhigang Wang who is _____ personally known or X proved to me on the basis of satisfactory evidence to be the person who acknowledged the foregoing instrument of assignment to be X his or _____ her free act and deed.



[Signature]
Notary Public

Assignment to Advanced Micro Devices, Inc.

In consideration of good and valuable consideration, receipt of which is hereby acknowledged, I/we

Tien-Chun Wang Yang (TC)
do hereby sell, assign, and transfer unto Advanced Micro Devices, Inc (hereinafter called AMD), a Delaware Corporation having its principal place of business at One AMD Place Sunnyvale, CA 94088-3453, and its successors and assigns, the entire right, title, and interest for the United States and all foreign countries, in and to any and all improvements, including the right of priority in, to, and under, the application for the United States patent entitled:

METHOD OF DETERMINING GATE OXIDE THICKNESS OF AN OPERATIONAL MOSFET

X filed herewith and the inventions set forth and described therein, and any and all Letters Patent of the United States and of countries foreign thereto which may be granted thereon or therefor; or

Serial No.: _____ filed on _____ and the inventions set forth and described therein, and any and all Letters Patent of the United States and of countries foreign thereto which may be granted thereon or therefor;

And for the above consideration, I/we agree promptly upon request of AMD, its successors or assigns, to execute and deliver without further compensation any power of attorney, assignment, application, whether original, continuation, divisional or reissue, or other papers which may be necessary or desirable fully to secure to AMD, its successors and assigns, the inventions described in said application and all patent rights therein, in the United States and in any country foreign thereto, and to cooperate and assist in the prosecution of interference proceedings involving said inventions and in the adjudication or reexamination of said Letters Patent provided the expenses which may be incurred by me/us in lending such cooperation and assistance are paid by AMD.


I/we further covenant with AMD, its successors, assigns, and legal representatives that no assignment, grant, mortgage, license, or other agreement affecting the rights and property herein conveyed has been made to others by the undersigned, and that full right to convey the same as herein expressed is possessed by the undersigned;

In witness whereof, I/we hereunto set my/our hand(s) and seal:

Inventor's Signature: Tien-Chun Yang Date: 12/10/01

State of California
County of Santa Clara

Before me this 10th day of December, 2001 personally appeared Tien-Chun Yang
who is _____ personally known or X proved to me on the basis of satisfactory evidence to be the person
who acknowledged the foregoing instrument of assignment to be X his or _____ her free act and deed.

Notary Stamp/Seal
 MORENA G. PACHECO
Commission # 1230694
Notary Public - California
Santa Clara County
My Comm. Expires Jul 30, 2003

Morena G. Pacheco
Notary Public